L Number	Hits	Search Text	DB	Time stamp
10	21610	(g01n021/88).ipc.	EPO; JPO; DERWENT; IBM_TDB	2004/03/15 11:49
11	651	((g01n021/88).ipc.) and ((semiconduct$ wafer) near (inspect$ defect$))	EPO; JPO; DERWENT; IBM_TDB	2004/03/15 11:50
12	121	(((g01n021/88).ipc.) and ((semiconduct$ wafer) near (inspect$ defect$))) and (laser fourier)	EPO; JPO; DERWENT; IBM_TDB	2004/03/15 11:51

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